

Notice of References Cited	Application/Control No. 10/711,842		Applicant(s)/Patent Under Reexamination REITER, MARKUS	
	Examiner THOMAS W. IRVIN		Art Unit 3683	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,192,249 A	03-1993	Nagano, Masashi	474/160
*	B	US-5,192,248 A	03-1993	Nagano, Masashi	474/140
*	C	US-5,299,925 A	04-1994	Chang, David	474/160
*	D	US-5,409,422 A	04-1995	Feng et al.	474/156
*	E	US-5,514,042 A	05-1996	Liou, Yan-Shing	474/160
*	F	US-5,738,603 A	04-1998	Schmidt et al.	474/158
*	G	US-5,782,712 A	07-1998	Campagnolo, Valentino	474/152
*	H	US-5,876,159 A	03-1999	Tseng et al.	409/51
*	I	US-5,876,296 A	03-1999	Hsu et al.	474/160
*	J	US-2001/0039224 A1	11-2001	Lim et al.	474/160
*	K	US-2002/0086753 A1	07-2002	Yahata, Yasuhiro	474/160
*	L	US-2004/0043855 A1	03-2004	Wei, Yu	474/160
*	M	US-2004/0142782 A1	07-2004	Kamada et al.	474/160

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.